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Attorney Docket: 622/48561
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Applicant: MARTIN DUBS ET AL.

Serial No.: 09/484,421

Group Art Unit: 1753

Filed: JANUARY 18, 2000

Examiner: CANTELMO, G



Title: SPUTTER CHAMBER AS WELL AS VACUUM TRANSPORT
CHAMBER AND VACUUM HANDLING APPARATUS WITH
SUCH CHAMBERS

LETTER REQUESTING DRAWING CHANGE APPROVAL

Commissioner for Patents
Washington, D.C. 20231

Sir:

Subject to the approval of the Examiner, please correct Fig. 3 in accordance with the attached red-line print to more clearly identify the radius of the locus of the largest erosion depth of the toroid-field erosion ditch r_T defining the radius of the sputter surface.

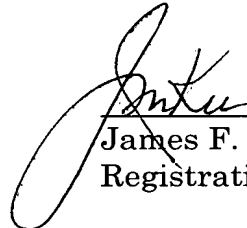
If there are any questions regarding this amendment or the application in general, a telephone call to the undersigned would be appreciated since this should expedite the prosecution of the application for all concerned.

If necessary to effect a timely response, this paper should be considered as a petition for an Extension of Time sufficient to effect a timely response, and

please charge any deficiency in fees or credit any overpayments to Deposit
Account No. 05-1323 (Docket #622/48561).

Respectfully submitted,

December 14, 2001



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